



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): SATOH, Yoshihiro

Serial No.: 09/981,402

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Title: Semiconductor Device and Method for
Its Manufacture

Attorney Docket No.: N320402-00W

Group Art Unit: 2815

Examiner: Richards, D.

NE
13/Response
w/ATT
P. Walker
8-4-03

RESPONSE TO FINAL OFFICE ACTION

5 Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

10 A. Introductory Comments

The following is submitted in response to the FINAL Office Action dated May 23, 2003.
The two month Advisory Action period ends July 23, 2003.

15 This response is presented in the revised amendment format set forth in 1265 Off. Gaz.
Pat. Office 87 (Dec. 17, 2002) and so is subject to waiver of the provisions of 37 C.F.R. §1.21(a),
(b) and (c).

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30 I hereby certify that this correspondence is being 37 C.F.R. §1.8

[] transmitted via facsimile to the United States Patent and Trademark Office to fax number: _____
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35 ☒ deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents,
P.O. Box 1450, Alexandria VA 22313-1450.

Date of Deposit: July 21, 2003

40 Typed/Printed Name: Darryl Walker

Signature: Darryl Walker